



AF/282

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Katsumi MIYATA, et al.

Group Art Unit: 2827

Serial No.: 09/478,508

Examiner: **GRAYBILL, D.**

Filed: **January 6, 2000**

P.T.O. Confirmation No.: 1796

For: **SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME**

RESPONSE UNDER 37 CFR §1.116

- EXPEDITED RESPONSE -

GROUP ART UNIT 2827

BOX AF

Commissioner for Patents
Washington, D.C. 20231

Sir:

RECEIVED
JAN 28 2003
TECHNOLOGY CENTER 2800
January 23, 2003

In response to the Office Action dated November 8, 2002, please amend the above-identified application as follows: